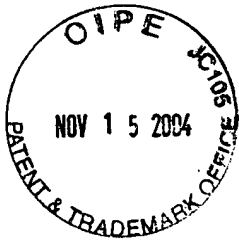


LFW



Docket No. F-7951

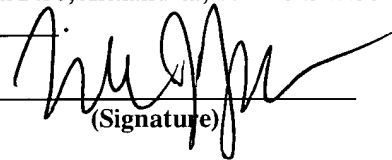
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Syunji HASUO, et al.
Serial No. : 10/657,337
Filed : September 8, 2003
For : ANODIZATION-ADAPTED ALUMINUM ALLOY
AND PLASMA-TREATING APPARATUS MADE
THEREOF
Group Art Unit : 1775
Examiner : Jennifer C. McNeil
Confirmation No. : 1660
Customer No. : 000028107

Certificate of Mailing Under 37 CFR 1.8

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Frank J. Jordan
(Name)


(Signature)

MAIL STOP Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Sir:

In response to the Office Action of August 11, 2004 please amend the above-identified patent application as follows: